

Claims

What is claimed is:

- 1 1. A rotary cathode device, comprising:
2 a conducting member disposed within a rotary cathode for coupling electrical
3 current from a power supply to a brush assembly, the conducting member
4 being made of an electrically conductive material; and
5 an electromagnetic field shield disposed between the conducting member and an
6 outer surface of the rotary cathode.
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- 1 2. A rotary cathode device of claim 1 wherein the conducting member comprises a
2 coolant conduit.
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- 1 3. A rotary cathode device of claim 1 the electromagnetic field shield forms at least
2 part of a drive shaft portion of the rotary cathode.
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- 1 4. A rotary cathode device of claim 1 wherein the electromagnetic field shield
2 comprises electromagnetic field-permeable material.
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- 1 5. A rotary cathode device of claim 1 further comprising a drive shaft portion of the
2 rotary cathode, the electromagnetic field shield being disposed between the
3 conducting member and the drive shaft portion.

1 6. A rotary cathode device of claim 5 wherein the drive shaft portion has a bore
2 passing there through such that the drive shaft portion includes an interior
3 surface adjacent the bore, the electromagnetic field shield being adjacent to at
4 least a portion of the interior surface of the drive shaft portion.

1 7. A rotary cathode device of claim 1 further comprising a drive shaft portion of the
2 rotary cathode which forms at least a portion of the outer surface of the rotary
3 cathode, the electromagnetic field shield being adjacent to at least a portion of an
4 outer surface of the drive shaft portion.

1 8. A high-power ion sputtering magnetron having a rotary cathode device of claim 1.

1 9. A rotary cathode device connectable to a power supply of electrical current, said
2 rotary cathode device comprising:
3 a coolant conduit disposed within the rotary cathode device made of an
4 electrically conductive material for connecting the electrical current from
5 the power supply to the rotary cathode; and
6 a drive shaft portion made of a ferrous material for absorbing the electromagnetic
7 field to reduce heat damage to parts adjacent to the coolant conduit that
8 are susceptible to inductive magnetic heating.

1 10. A high-power ion sputtering magnetron, comprising:
2 a rotary cathode disposed upon the magnetron device, the rotary cathode
3 comprising a conducting member disposed within the rotary cathode for
4 coupling electrical current from a power supply to a brush assembly, the
5 conducting member being made of an electrically conductive material, the
6 rotary cathode further comprising an electromagnetic field shield disposed
7 between the conducting member and an outer surface of the rotary
8 cathode.

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1 11. A magnetron device of claim 10 wherein the conducting member comprises a
2 coolant conduit.

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1 12. A magnetron device of claim 10 wherein the electromagnetic field shield forms at
2 least part of a drive shaft portion of the rotary cathode rotatably disposed upon
3 the magnetron device.

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1 13. A magnetron device of claim 10 wherein the electromagnetic field shield
2 comprises electromagnetic field-permeable material.

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1 14. A magnetron device of claim 10 wherein the rotary cathode further comprises a
2 drive shaft portion of the rotary cathode, the electromagnetic field shield being
3 disposed between the conducting member and the drive shaft portion.

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15. A magnetron device of claim 14 wherein the rotary cathode drive shaft portion has a bore passing there through such that the drive shaft portion includes an interior surface adjacent the bore, the electromagnetic field shield being adjacent to at least a portion of the interior surface of the drive shaft portion.

16. A magnetron device of claim 10 wherein the rotary cathode further comprises a drive shaft portion of the rotary cathode which forms at least a portion of the outer surface of the rotary cathode, the electromagnetic field shield being adjacent to at least a portion of an outer surface of the drive shaft portion.

17. A high-power ion sputtering magnetron connectable to an electrical power supply, said magnetron device comprising:
a rotary cathode rotatably mounted upon the magnetron device, said rotary cathode comprising a conducting member disposed within the rotary cathode, said conducting member being made of an electrically conductive material for connecting the electrical current from the power supply to the rotary cathode; and
a drive shaft portion rotatably mounted to the magnetron device, said drive shaft portion being made of a ferrous material for absorbing the electromagnetic field to reduce heat damage to parts adjacent to the conducting member that are susceptible to inductive magnetic heating.